### Record of Letter Ballot Review by TC Chapter for Procedural Review

Region/Locale: Japan

**Global Technical Committee: Silicon Wafer** 

TC Chapter Cochairs: T. Nakai /SUMCO, N. Kawai /Meiji University

Standards Staff: J. Collins

	Scheduled in Background Statement	Actual
Date	12/14/2017	12/14/2017
Location	Tokyo Big Sight, Tokyo Japan	Tokyo Big Sight, Tokyo Japan
Reason for Change of Date and/or Location (if changed)		

Note: See *Regulations* ¶ 9.5 Exception for allowable reason to change.

#### I. Document Number and Title

<b>Document Number</b>	Document Title
6280	REAPPROVAL OF SEMI MF576-0812
	TEST METHOD FOR MEASUREMENT OF INSULATOR
	THICKNESS AND REFRACTIVE INDEX ON SILICON
	SUBSTRATES BY ELLIPSOMETRY

## **II. Tally**

Standards staff to fill in.

Voting Tally: As-cast tally after close of voting period

Note: A minimum of 60% of the Voting Interests that have TC Members within the global technical committee that issued the Letter Ballot must return Votes. (*Regulations* ¶ 9.7.1.1)

#### **Voting Tally (with example values):**

Returned Votes		Distribution		Return Rate	
57	÷	95	=	60.0%	≥60%
25	L				
0		Total Voters with Rejects		0	
32					
	57 25 0	57 ÷ 25	57 ÷ 95  25  0 Total	57 ÷ 95 =  25  0 Total Vote:	57 ÷ 95 = 60.0%  25  0 Total Voters with Rejects

Note: See Regulations § 3.2.1 for definition of Voting Interest.

# III. Rejects: No Rejects

#### IV. Other Technical Issues: None

Note: TC Chapter may choose to address a technical issue that is not part of a Negative received on a Letter Ballot (i.e., a Comment or a reason not addressed by a Vote response) by handling it as a Negative and finding it related and technically persuasive. The TC Chapter may then fail the Document or address such technical issue by using the procedure defined in *Regulations* § 9.6.4.3 to make a technical change to the Document. (*Regulations* ¶ 9.6.2.4.5)

#### V. Comments: No comments

### VI. Editorial Changes Other than Those Voted on in § V: None

Original section/paragraph number and at least one full sentence are required in "FROM" and "TO" fields.

## **VII. Approval Conditions Check**

### VII. - (i). Approval Rate

APPROVAL CONDITION 1: All Negatives have been discussed and were withdrawn, found not related, found not persuasive, or addressed by a technical change. (*Regulations* ¶ 9.7.1.2)

APPROVAL CONDITION 2: At least 90% of the sum of valid Voting Interest Accept and Voting Interest Reject Votes must be Accept. (*Regulations* ¶ 9.7.1.3)

Note: If both approval conditions are not satisfied, the Document fails.

		Accepts		(Accepts + Valid Rejects)			
Approval Rate	=	32	/	32	=	100.0%	≥90%

### VII. – (ii) Approval Level (check one)

Note: See Regulations § 9.7.2 for further information.

X

## Globally Approved (No Ratification Ballot needed):

The Letter Ballot meets the Letter Ballot approval conditions for the global technical committee.



The Letter Ballot meets the Letter Ballot approval conditions for the TC Chapter and a Ratification Ballot will be issued to validate technical changes.

# **VIII. Safety Check**

Note: See Regulations § 15 for further information.

	X	Th is	This is not a Safety Document, when all safety-related information is removed, the Document s still technically sound and complete. ( <i>Regulations</i> ¶ 8.7.1)						
Motion	This is a Safety Document, when all safety-related information is removed, the Document not technically sound and complete. ( <i>Regulations</i> ¶ 8.7.2)								
		Safety Checklist ( <i>Regulations</i> ¶ 15.3) is complete and has been included with the Docuthroughout the balloting process. ( <i>Regulations</i> ¶ 15.1.2)							
	Moti	otion by/2 <sup>nd</sup> by Ryuji Takeda (GlobalWafers Japan)/ Tsuyoshi Otsuki (SEH)							
	Discussion			None					
	Vote			11 Y-0 N; Motion passed					

# IX. Intellectual Property (IP) Check

Note: This Letter Ballot may cover all or part of a Standard or Safety Guideline. This IP check applies to the entire Standard or Safety Guideline. See *Regulations* § 16 for further information.

The TC Chapter meeting chair asked those participating, if they were aware of any potentially material patented technology or copyrighted items* in the Standard or Guideline. ( <i>Regulations</i> ¶ 8.8.1)									
X			ntially material patented technology or reproduction of nted items is known.						
	copy copy	Potentially material patented technology or reproduction of copyrighted items is known, but a Letter of Assurance (LOA) or copyright release letter for such items has been obtained or presented to the TC Chapter.							
	use o	Potentially material patented technology or reproduction of copyrighted items is known and use of such materials is technically justified by the TC Chapter, but an LOA or copyright release letter for some of the item(s) has NOT been obtained or presented to the TC Chapter.							
M		Ask ISC f	or spec	cial permission to publish.					
Motion		Quit activ	vity.						
'n		Wait for L	LOA for patented technology or release of copyrighted items.						
Mot	ion by	y/2 <sup>nd</sup> by							
Discussion				XXXX					
	Vot	te	XX Y-XX N						
	Final Astinu			Motion passed					
Final Action				Motion failed					

<sup>\*</sup> Note: Such potentially material patented technology or copyrighted items might have become known since the Standard or Safety Guideline was last reviewed, or might become relevant due to this Letter Ballot.

# X. Action for This Document

	X	This Document passed TC Chapter review as balloted and will be forwarded to the ISC A&R SC for procedural review.							
M		This Document passed TC Chapter review with editorial changes and will be forwarded to the ISC A&R SC for procedural review.							
Motion		editorial ch	ment passed TC Chapter review with technical changes and with or without hanges and will be forwarded to the ISC A&R SC for procedural review. A n Ballot will be issued to verify the technical changes.						
		This Docui	ment failed TC Chapter review and will be returned to the TF for rework.						
		This Docui	ment failed TC Chapter review and work will be discontinued.						
ı	Motion by/ 2 <sup>nd</sup> by		Ryuji Takeda (GlobalWafers Japan)/ Tsuyoshi Otsuki (SEH)						
[	Disc	ussion	None						
	٧	ote	11 Y-0 N						
F	inal	Action	X Motion passed						
	iiiai	Action	Motion failed						

Standards staff to record the result of the A&R procedural review here:

Approved pending acceptance of the Ratification Ballot	